

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Wen-Jian et al.
Appl. No. : 10/815,905
Filed : March 31, 2004
For : INTERFEROMETRIC MODULATION PIXELS AND
MANUFACTURING METHOD THEREOF
Examiner : Tran, Hoang Q
Group Art Unit : 2874

RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully request consideration of the following Remarks in response to the Office Action sent May 10, 2007 ("Office Action").

Summary of Interview begins on page 2 of this paper

Remarks begin on page 3 of this paper.